



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 6540**  
Minoru NAKANO : Attorney Docket No. 2002-0046A  
Serial No. 10/050,101 : Group Art Unit 2193  
Filed January 18, 2002 : Examiner John Q. Chavis  
SYSTEM FOR SUPPLYING : **MAIL STOP: RCE**  
SEMICONDUCTOR MANUFACTURING  
SYSTEM CONTROL PROGRAMS

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**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

In response to the Office Action of March 27, 2006, the period for response to which having been extended by three months to September 27, 2006, kindly amend the above-referenced U.S. patent application as follows: